



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hisaji OYAKE et al.

Group Art Unit: 2854

Application No.: 10/500,816

Examiner: A. NGUYEN

Filed: July 7, 2004

Docket No.: 120321

For: METHOD OF MANUFACTURING STAMPER FOR MANUFACTURING
INFORMATION MEDIUM, STAMPER, AND PHOTORESIST MASTER

AMENDMENT UNDER 37 C.F.R. §1.114

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the August 16, 2006, Office Action, the period for reply being extended by the attached Petition for Extension of Time, and in reply to the December 5, 2006 Advisory Action, and in consideration of the attached Request for Continued Examination, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.